



#7

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2841
Examiner: To be assigned

In Re PATENT APPLICATION Of:

Applicants	:	OHUCHI et al.)
Serial No.	:	09/843,650)
Filed	:	April 27, 2001)
For	:	SEMICONDUCTOR APPARATUS AND METHOD FOR FABRICATING THE SAME	REQUEST FOR CORRECTED FILING RECEIPT
Attorney Ref.	:	IIZ 123)

Commissioner of Patents
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Sir:

Please correct the Official Filing Receipt in the above-captioned matter as follows:
-Change the number of Independent Claims to "3" instead of "4".
-Change both of the applicant's residence to "Tokyo, JAPAN".

It is believed that the inaccuracies are the fault of the United States Patent and Trademark Office, and therefore, that no fee is due. However, if it is determined that a fee is due, please charge such fee to our Deposit Account No. 18-0002.

Respectfully submitted,



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Date: August 27, 2001

SMR:mrd

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APPLICATION NUMBER	FILING DATE	GRP/ART UNIT	FIL FEE REC'D	ATTY/DOCKET NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/843,650	04/27/2001	2841	0.00	IIZ 123	23	22	X 3

CONFIRMATION NO. 7849

FILING RECEIPT



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JUN 29 2001

Date Mailed: 06/22/2001

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and, TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Domestic Priority data as claimed by applicant

Foreign Applications

JAPAN 2000-128764 04/28/2000

If Required, Foreign Filing License Granted 06/22/2001

Projected Publication Date: To Be Determined - pending completion of Missing Parts

Non-Publication Request: No

Early Publication Request: No

Title

Semiconductor apparatus and method for fabricating the same

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Initial Patent Examination Division (703) 308-1202

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